

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Inventor.....John T. Moore
Assignee.....Micron Technology, Inc.
Priority Group Art Unit2815
Priority Examiner Wojciechowicz
Attorney's Docket No.MI22-2438
Title: (As amended) Methods of Forming Dielectric Materials and Methods of Processing
Semiconductor Substrates

PRELIMINARY AMENDMENT

To: MS Patent Application
Commissioner for Patents
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AMENDMENTS

Introductory Comments

Applicant amends the application and remarks as follows.